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| SERIAL NUMBER 10/735,912 | FILING DATE 12/16/2003 RULE | CLASS 118 | GROUP ART UNIT 1763 | ATTORNEY DOCKET NO. 040021-0306769 | |
| APPLICANTS Seung-Chul Choi, Seoul, KOREA, REPUBLIC OF; ** CONTINUING DATA ***** ** FOREIGN APPLICATIONS ***** REPUBLIC OF KOREA 10-2002-0080762 12/17/2002 IF REQUIRED, FOREIGN FILING LICENSE GRANTED ** 03/23/2004 | | | | | |
| Foreign Priority claimed <input checked="" type="checkbox"/> yes <input type="checkbox"/> no 35 USC 119 (a-d) conditions <input checked="" type="checkbox"/> yes <input type="checkbox"/> no <input type="checkbox"/> Met after met Verified and <u>Allowance</u> Acknowledged <u>Examiner's Signature</u> Initials | | STATE OR COUNTRY KOREA, REPUBLIC OF | SHEETS DRAWING 3 | TOTAL CLAIMS 13 | INDEPENDENT CLAIMS 2 |
| ADDRESS 00909 PILLSBURY WINTHROP SHAW PITTMAN, LLP P.O. BOX 10500 MCLEAN, VA 22102 | | | | | |
| TITLE Chemical vapor deposition apparatus and method | | | | | |
| FILING FEE RECEIVED 770 | FEES: Authority has been given in Paper No. _____ to charge/credit DEPOSIT ACCOUNT No. _____ for following: | | <input type="checkbox"/> All Fees <input type="checkbox"/> 1.16 Fees (Filing) <input type="checkbox"/> 1.17 Fees (Processing Ext. of time) <input type="checkbox"/> 1.18 Fees (Issue) | | |